

 Implementation of Precision Agriculture
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An Integrated System for Mapping Soil Physical Properties On-the-Go (the Mechanical Sensing Component)

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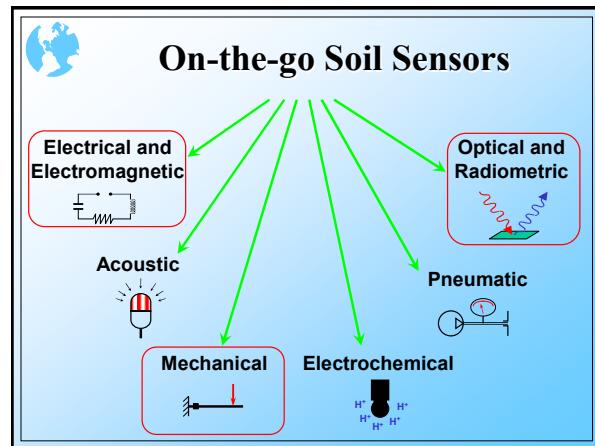
Presentation Outline

- **Background**
 - Problem statement and history of sensor development
 - Overview of integrated mapping of soil physical attributes
- **Materials and Methods**
 - Vertical blade with an array of strain gage bridges
 - Long-term tillage plots experiment
- **Results and Discussion**
 - Comparison of tillage practices using on-the-go measurements of soil mechanical resistance
 - Field mapping
 - Overview of the latest prototype system
 - Summary



Problem Statement

- The assessment of soil variability is one of the most important steps in site-specific management
- Conventional means to attain soil variability data are incapable of accurately identifying spatial inconsistency within a production field at an economically feasible cost
- There is a need to develop equipment for mapping soil attributes on-the-go
- On-the-go sensing technology must be reliable, rapid, simple, inexpensive, repeatable





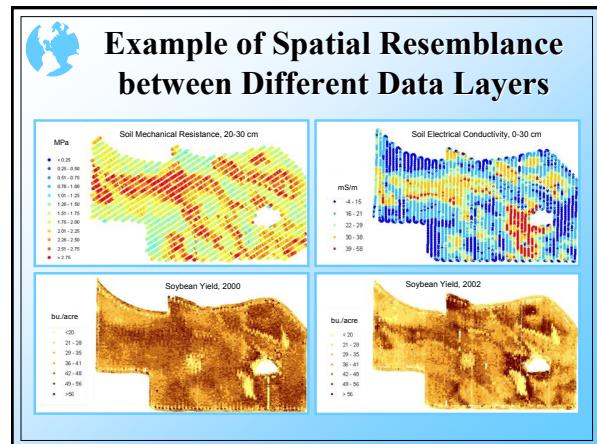
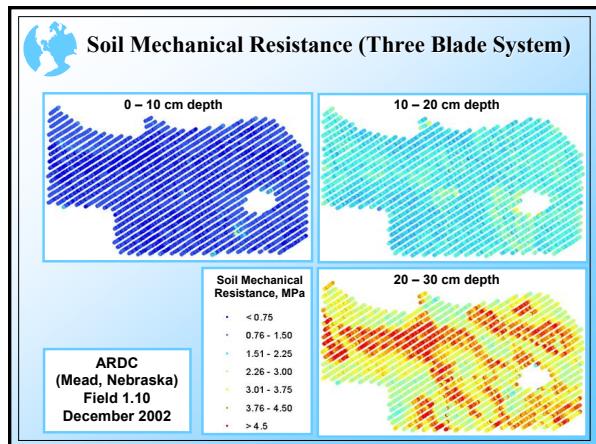
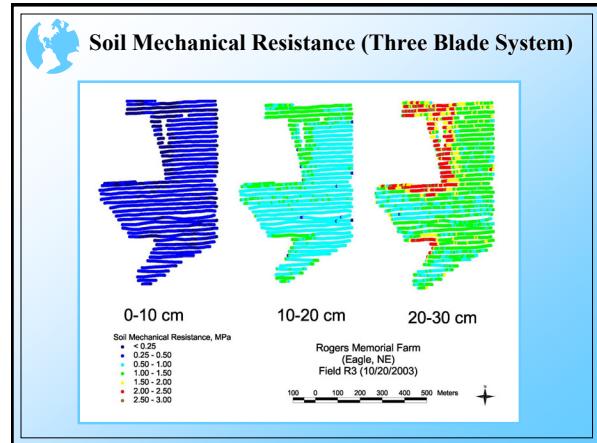
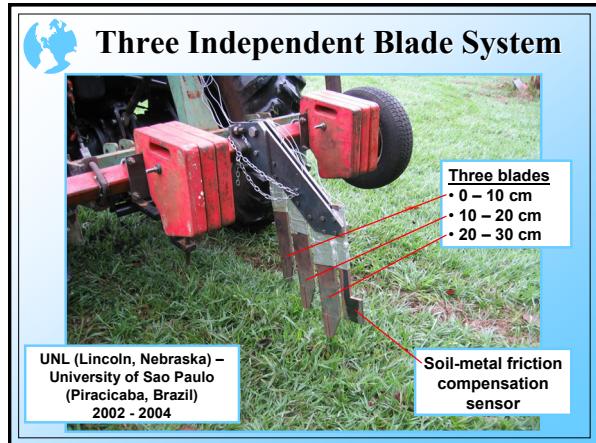
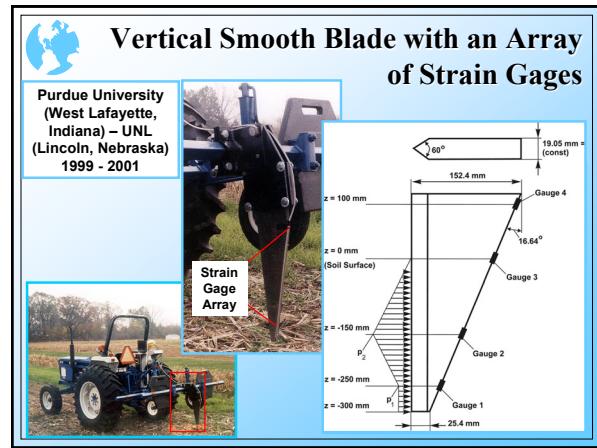
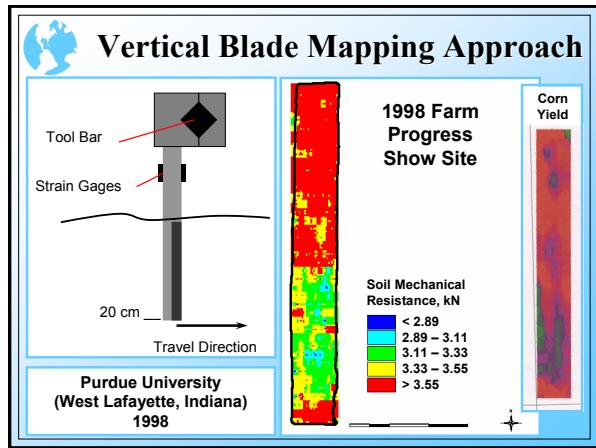
Applicability of On-the-Go Soil Sensors

Soil property	Good	OK	Some
Soil texture (clay, silt and sand)	Good	OK	Some
Soil organic matter or total carbon	Some	Good	
Soil water (moisture)	Good	Good	
Soil salinity (sodium)	OK		Some
Soil compaction (bulk density)		Good	Some
Depth variability (hard pan)	Some	OK	Some
Soil pH		Some	Good
Residual nitrate (total nitrogen)	Some	Some	
Other nutrients (potassium)		Some	OK
CEC (other buffer indicators)	OK	OK	



Integrated Mapping Approach

- **Instrumented blade**
 - Compacted field areas
 - Soil mechanical resistance profile
 - Blade with an array of strain gage bridges
 - Sensing depth down to 30 cm
 - Minimum soil disturbance
- **Capacitor-type sensor**
 - Volumetric water content
 - Dielectric soil properties measurement
- **Optical sensor**
 - Organic matter content
 - Soil reflectance at 470 and 660 nm
 - Direct soil contact through a sapphire window



Integrated Soil Physical Properties Mapping System (ISPPMS)

UNL (Lincoln, Nebraska) 2004

Two wavelengths soil reflectance sensor

Soil mechanical resistance profiler with an array of strain gage bridges

Capacitor-based sensor

“Organic Matter” Sensor

Cross-section of the sensor

Shank

660 nm LEDs

Photodiode

Purdue University (West Lafayette, Indiana) 1988 - 1992

UNL (Nebraska, Lincoln) 2004 - 2005

Capacitor-Based Sensor

UNL (Lincoln, Nebraska) – Retrokool (Berkeley, California) 2001-2003

Silty clay loam soil

Triple replicates

Two tests

Sensor Output, V

Gravimetric Soil Moisture, g/g

Instrumented Blade with a Half-Split Cutting Edge

Direction of travel

Actual soil surface

Apparent soil surface

Second order polynomial model

Cutting edge

Discrete reaction forces

Vertical location:

- Gage 1
- Gage 2
- Boss A Gage 3
- Boss B Gage 4
- Boss C

5 – 30 cm measurement depth

Tillage Treatment Experimental Plots

Plot	Tillage treatment	Maximum depth of tillage, cm	Gravimetric moisture content, g/g
A	plowed and double disked	20	0.26 - 0.28
B	disked	13	0.24 - 0.26
C	no-till with cultivation	5	0.24 - 0.27
D	chiselled and disked	30	0.23 - 0.26
E	double disked	13	0.24 - 0.25
F	no-till w/o cultivation	0	0.25 - 0.29

Twenty years history

Controlled wheel traffic

Five cone penetrometer profiles

Five on-the-go measurements (1 Hz)

